

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| Applicant(s): KATSUMATA et al. | Atty. Dkt.: 01-564 |
| Serial No.: Unknown | Group Art Unit: |
| Filed: Concurrently herewith | Examiner: |
| Title: SEMICONDUCTOR PRESSURE SENSOR HAVING DIAPHRAGM | |

Commissioner for Patents
Arlington, VA 22202

Date: February 26, 2004

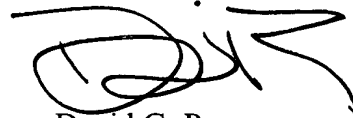
INFORMATION DISCLOSURE STATEMENT

Sir:

Pursuant to 37 C.F.R. §1.56, the reference(s) listed on the attached Form PTO-1449 is/are submitted for consideration by the Examiner without any admission that it/they constitute(s) statutory prior art, or without any admission that it/they contain(s) subject matter that anticipates the invention or renders the invention obvious to a person of ordinary skill in the art.

The Examiner is requested to initial the attached PTO Form-1449 and to return a copy of same to the undersigned attorney as proof that the listed reference(s) has/have been considered and made of record.

Respectfully submitted,



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| FORM PTO-1449 | ATTY. DKT NO. | 01-564 | SER. NO. |
| | APPLICANT | KATSUMATA et al. | |
| | FILING DATE | February 26, 2004 | GROUP |

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

| EXAMINER INITIAL | | DOCUMENT NUMBER | DATE | NAME | CLASS | SUB CLASS |
|------------------|--|---|---------------|-----------------|-------|-----------|
| | | 6,601,452 (Discussed on page 1 of the spec) | Aug. 5, 2003 | Murata et al. | | |
| | | 6,595,065 (Discussed on page 2 of the spec.) | July 22, 2003 | Tanizawa et al. | | |
| | | 5,289,721 | Mar. 1, 1994 | Tanizawa et al. | | |

FOREIGN PATENT DOCUMENTS

TRANSLATION

| | | DOCUMENT NUMBER | DATE | COUNTRY | NAME | CLASS | SUB CLASS | YES | NO | |
|--|--|-----------------|------|---------|------|-------|-----------|-----|----|---------------|
| | | | | | | | | | | Eng. Abstract |
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* Full English text is available in machine-translated form in JPO (Japanese Patent Office) English language web site at <http://www1.ipdl.jpo.go.jp/PA1/cgi-bin/PA1INDEX>.

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, etc.)

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|----------|--|-----------------|
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| EXAMINER | | DATE CONSIDERED |